


<b>Search Notes</b>  	<b>Application/Control No.</b>  10596963	<b>Applicant(s)/Patent Under Reexamination</b>  LEHTONEN, KAI
	<b>Examiner</b>  Christopher S Kim	<b>Art Unit</b>  3752

SEARCHED			
Class	Subclass	Date	Examiner
239	88-95, 570-574, 533.3-533.12		
137	494, 543.15, 514.5		
123	446-447, 496, 500-501, 50 6	9/20/09	CK
Updated		1/9/2010	CK

SEARCH NOTES		
Search Notes	Date	Examiner
137/ J. Rivell		
123/ T. Moullis (X-re in 123/496)	9/20/09	CK

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner
EAST		1/9/2010	CK

--	--